

APR 18 2006

S/N 10/804,610

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	KITAOKA, et al.	Examiner:	T. Ho
Serial No.:	10/804,610	Group Art Unit:	2818
Filed:	March 18, 2004	Docket:	10873.1420US01
Title:	METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND SEMICONDUCTOR DEVICE		

CERTIFICATE UNDER 37 CFR 1.6(d): I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on April 18, 2006.

By: *Peggy Kerkhove*  
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REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that this application be accorded the benefits of Continued Examination in accordance with the provisions of 37 C.F.R. §1.114.

A submission meeting of requirements of 37 C.F.R. 1.111 accompanies this paper; or

Please enter the amendment previously filed on \_\_\_\_\_ but not entered.

Please charge the required filing fee of \$790.00 for a large entity to the Deposit Account No. 50-3478. Please charge any additional fee or credit any overpayment to Deposit Account No. 50-3478.

Respectfully submitted,

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